

Indirect excitons in a potential energy landscape created by a perforated electrode

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We report on the principle and realization of an excitonic device: a ramp that directs the transport of indirect excitons down a potential energy gradient created by a perforated electrode at a constant voltage. The device provides an experimental proof of principle for controlling exciton transport with electrode density gradients. We observed that the exciton transport distance along the ramp increases with increasing exciton density. This effect is explained in terms of disorder screening by repulsive exciton-exciton interactions. © 2016 AIP Publishing LLC.

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An indirect exciton (IX) is a bound state of an electron and hole in spatially separated quantum wells (QWs) [Fig. 1(a)]. The spatial separation reduces the overlap of the electron and hole wavefunctions, resulting in IX lifetimes that are orders of magnitude longer than those of direct excitons. Long lifetimes enable the IXs to travel over large distances before recombination.^{1–12} Due to the spatial separation, the IXs also acquire a built-in dipole moment ed , where d is the approximate distance between the QW centers. The dipole moment can be explored to control the IX energy: an electric field F_z applied perpendicular to the QW plane shifts the IX energy by $E = -edF_z$.¹³ These properties are advantageous for creating excitonic devices and studying the transport of IXs in electrostatic in-plane potential landscapes $E(x, y) = -edF_z(x, y)$.

IX transport has been studied in various potential landscapes that were created by laterally modulated voltage $V(x, y)$. These potential landscapes include ramps,^{1,6,14} lattices,^{15,16} traps,^{17–20} circuit devices,^{21–24} narrow channels,^{23,25,26} conveyers,²⁷ and rotating potentials.²⁸ A set of exciton transport phenomena has been observed, including the inner ring in exciton emission patterns,^{4,7,8,11,29,30} transistor effect for excitons,^{21–24} exciton localization-delocalization transition in random potentials,^{4,7,8} lattices,^{15,16} and moving potentials,^{27,28} coherent exciton transport with suppressed scattering,^{31,32} and both spin transport and textures.³³

An alternative method for creating potential landscapes for IXs was proposed in Ref. 34, which is based on the lateral modulation of the electrode density rather than voltage. Divergence of the electric field around the periphery of an electrode reduces the normal component F_z . This enables one to control F_z , and thereby the potential energy landscape for IXs, by adjusting only the electrode density while keeping the entire device at a constant, uniform voltage. This method is beneficial compared to the voltage modulation method because it does not require an energy dissipating voltage gradient. One instance of this method based on

varying the electrode width—the shaped electrode method—has been used to create confining potentials for IXs in traps¹⁸ and ramps.^{14,24}

In this work, we present an excitonic device based on the electrode density modulation in which a potential energy gradient is created by a perforated electrode at a constant

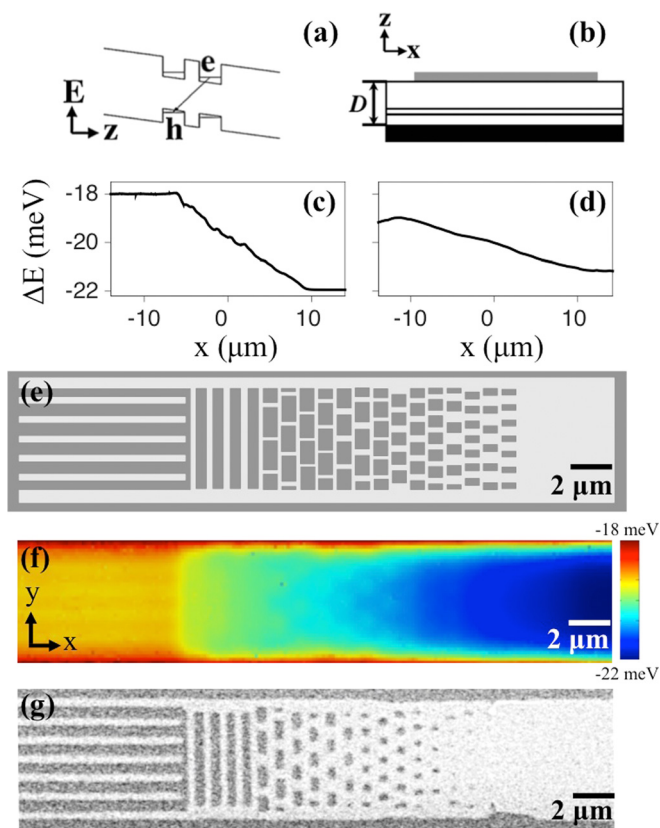


FIG. 1. (a) CQW energy band diagram; e, electron; h, hole. (b) Schematic of device. (c) Simulated potential energy $E(x, y) = -edF_z$ for IXs in the ramp. Applied voltage $V = -1.83$ V. (d) IX PL energy in the ramp. $V = -5$ V, $T_{\text{bath}} = 1.8$ K, $P_{\text{ex}} = 10$ μ W. (e) Ramp electrode (light gray) which forms the potential energy gradient by varying electrode density. (f) Calculated IX energy shift $E(x, y) = -edF_z$ in the ramp. (g) SEM image of the ramp electrode.

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voltage. One advantage of the perforated electrode method presented here is the absence of an energy dissipating voltage gradient, similar to a shaped electrode.^{14,24} However, the perforated electrode method also has additional advantages. The shaped electrode method requires a narrow exciton channel limiting the exciton fluxes through the channel. In contrast, the perforated electrode method does not require a narrow exciton channel and allows the width of the channel to be varied independent of the energy gradient. As a result, the perforated electrode method supports larger exciton fluxes than the shaped electrode method. The perforated electrode method gives the opportunity to create versatile potential landscapes for IXs and, in particular, create channels for directing exciton fluxes with the required geometry and energy profile. We present the proof of principle demonstration of the perforated electrode method to control IX energy and fluxes. We realized a potential energy gradient, a ramp, for IXs using a single perforated electrode of constant width and demonstrated IX transport along this ramp.

IXs were photoexcited by a 633 nm HeNe laser (focused to a spot with full width half maximum $6\ \mu\text{m}$) in a GaAs coupled QW structure (CQW) grown by molecular beam epitaxy [Figs. 1(a) and 1(b)]. Exciton photoluminescence (PL) was measured by a spectrometer and a liquid-nitrogen cooled CCD. In the CQW structure, an n^+ -GaAs layer with $n_{\text{Si}} = 10^{18}\ \text{cm}^{-3}$ serves as a homogeneous ground plane. Two 8 nm GaAs QWs are separated by a 4 nm $\text{Al}_{0.33}\text{Ga}_{0.67}\text{As}$ barrier and positioned 100 nm above the n^+ -GaAs layer within an undoped $D = 1\ \mu\text{m}$ thick $\text{Al}_{0.33}\text{Ga}_{0.67}\text{As}$ layer [Fig. 1(b)]. The CQWs are positioned close to the homogeneous electrode to suppress the in-plane electric field,³⁵ which could otherwise lead to exciton dissociation.³⁶ The top semitransparent electrode was fabricated by applying 2 nm Ti, 7 nm Pt, and 2 nm Au.

Figures 1(e) and 1(g) show a schematic of the electrode pattern and an SEM image of the electrode, respectively. The local electrode density, which controls the normal component F_z and, in turn, the IX energy shift $-e dF_z$, is determined by the fraction of the area perforated. The modulation of the electrode density along x is designed to create a ramp potential for IXs with a nearly constant energy gradient [Figs. 1(c) and 1(f)]. Figures 1(c) and 1(f) show that the perforated electrode creates a smooth ramp potential with the energy variations due to the perforations of $\sim 0.1 - 0.3\ \text{meV}$, significantly smaller than $\sim 1\ \text{meV}$ random potential fluctuations in the CQWs.¹⁵ Such energy variations due to the perforations create no substantial obstacles for the exciton transport along the ramp as confirmed by the IX transport measurement described below; perforations create a smooth potential with no significant obstacles for the exciton transport when the lateral dimensions of the perforations are comparable to (or smaller than) the intrinsic layer width D in the device.

Figure 1(d) shows the measured spatial profile of the IX energy. It is quantified by the first moment of the IX PL $E(x) = \int EI(x, E)dE/I(x)$, where $I(x) = \int I(x, E)dE$ is the IX PL intensity. The IX energy also includes the difference between the direct and indirect exciton binding energies, a few meV for the CQWs.³⁸ The simulated [Fig. 1(c)] and measured [Fig. 1(d)] spatial profiles of the IX energy are qualitatively similar. However, repulsively interacting IXs

screen an external potential, which reduces the energy gradient in the ramp [Fig. 1(d)] as discussed below.

The black curve in Fig. 2(a) shows the profile of the IX PL intensity $I(x)$ in a flat channel with no potential energy gradient. This channel was produced by a solid electrode strip of width $5\ \mu\text{m}$ with no perforations. The laser excitation profile is shown in gray. Figure 2(b) shows the corresponding spatial distribution of the IX PL. As there is no preferred direction of transport in the flat channel, two maxima that are nearly symmetric relative to the excitation spot position are observed. This phenomenon is consistent with the previously studied inner ring effect.^{4,7,8,11,29,30} The inner ring emission is an effect of excitons cooling down to low-energy optically active states³⁹ as they travel away from the hot optical excitation spot. Figure 2(c) shows the profile of the IX PL intensity and Fig. 2(d) shows the spatial distribution of IX PL in the ramp. The IX transport in the ramp is directed toward lower IX energy. Such a directed transport of IXs in the ramp is analogous to directed transport of electrons in a diode.

Since the electrode is semitransparent and the perforation density varies, the percentage of the signal transmitted through the electrode is not constant along the ramp. The dashed black line in Fig. 2(c) is an estimate of the PL intensity corrected for the varying electrode transparency. This estimation is described in supplementary materials along with other experimental details.³⁷ The PL intensity correction due to the electrode transparency variation is quantitative and results in an enhancement of IX transport distance [Fig. 2(c)].

Figure 3 shows the average IX transport distance, which is quantified by the first moment of the IX PL intensity $M_1 = \int xI(x)dx / \int I(x)dx$, as a function of laser excitation power P_{ex} . The transport distance increases with increasing P_{ex} up to $\sim 50\ \mu\text{W}$, an effect that can be attributed to the screening of disorder in the structure by repulsive exciton-exciton interactions. Repulsive interactions arise from the alignment of the excitons' electric dipole moments perpendicular to the QW plane. Disorder screening improves the IX

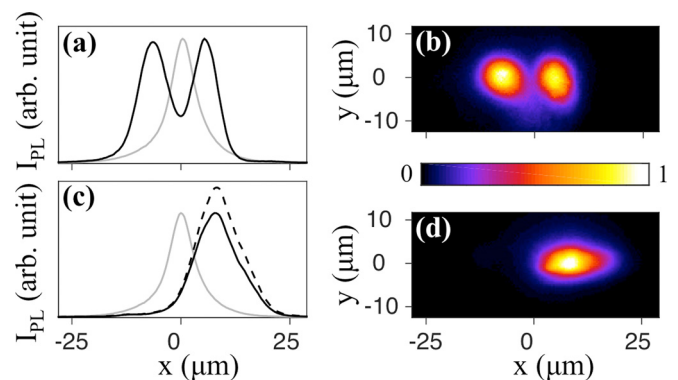


FIG. 2. (a) IX PL profile (black) in a channel with constant potential energy formed by an electrode of constant density. Laser excitation profile (gray). (b) Image of IX PL intensity in the channel with constant potential energy. In (a) and (b), the channel is created by a $5\ \mu\text{m}$ wide electrode with no perforations. (c) IX PL profile (solid black) in the ramp. Laser excitation profile (gray). Estimation of IX PL profile (dashed black) with correction for the electrode transparency. (d) Image of IX PL intensity in the ramp. For all data, the laser excitation is centered around $x, y = 0$, $P_{\text{ex}} = 10\ \mu\text{W}$, $T_{\text{bath}} = 1.8\ \text{K}$, and $V = -5\ \text{V}$.

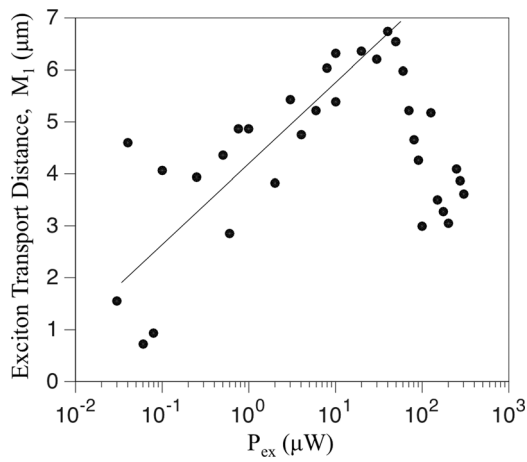


FIG. 3. The average transport distance of IXs M_1 along the ramp as a function of excitation power P_{ex} . $T_{\text{bath}} = 1.8$ K.

mobility and thereby increases IX transport distance along the ramp.^{7,40} This interpretation is supported by a theoretical model presented below. A drop of M_1 observed at the highest P_{ex} can be related to a photoexcitation induced reduction of F_z .

The transport of IXs was simulated for a smooth potential energy gradient matching that generated by our device. In this model, the energy variations due to the perforations were neglected since they are small compared with the disorder. Similar to our previous work,^{14,24} the following drift-diffusion equation is solved for the IX density, n_x :

$$\frac{\partial n_x}{\partial t} = \nabla [D_x \nabla n_x + \mu_x n_x \nabla (u_0 n_x + U_{\text{ramp}})] - \frac{n_x}{\tau_{\text{opt}}} + \Lambda. \quad (1)$$

We treat n_x as being homogeneous along y and use $\nabla = \partial/\partial x$, approximately matching the geometry of the ramp. The first and second terms in the square brackets in Eq. (1) are due to IX diffusion and drift, respectively. The diffusion coefficient, D_x , accounts for the screening of the intrinsic QW disorder potential by repulsively interacting IXs and is given by the thermionic model, $D_x = D_{x0} e^{-U_0/(u_0 n_x + k_B T)}$. Here, $U_0/2 = 0.75$ meV is the amplitude of the disorder potential and T is the exciton temperature. The exciton-exciton interaction potential is approximated by $u_0 n_x$ with $u_0 = 4\pi d e^2/\epsilon_b$ where ϵ_b is the background dielectric constant and $d = 11.5$ nm is the static dipole moment, corresponding to the center to center distance of the QWs.^{7,30,40} The drift term in Eq. (1) has contributions from the exciton-exciton interactions and the ramp potential, $U_{\text{ramp}} = -edF_z$. A generalized Einstein relationship defines the IX mobility, $\mu_x = D_x (e^{T_0/T} - 1)/(k_B T_0)$, where $T_0 = (\pi \hbar^2 n_x)/(2M_x k_B)$ is the quantum degeneracy temperature. The exciton generation rate, Λ , has a Gaussian profile whose width matches that of the laser excitation spot. τ_{opt} is the IX optical lifetime and includes the fact that only low energy excitons inside the light cone may couple to light.³⁹ The IX temperature, T , is determined by a thermalization equation

$$\frac{\partial T}{\partial t} = S_{\text{pump}}(T_0, T, \Lambda, E_i) - S_{\text{phonon}}(T_0, T). \quad (2)$$

Here, S_{pump} is the heating due to the laser which is characterized by the excess energy of photoexcited excitons,

$E_i = 17$ meV. S_{phonon} describes cooling by the emission of bulk longitudinal acoustic phonons. Model parameters and details of the calculation of S_{pump} , S_{phonon} , and τ_{opt} can be found in Refs. 7, 8, and 40. The coupled equations (1)–(2) describing the IX transport and thermalization kinetics are integrated in time until steady state solutions are obtained. The IX PL intensity is then calculated from the IX decay rate, taking into account the aperture angle of the CCD in the experiment.

The results of the simulations are presented in Fig. 4. Figure 4(a) shows the IX density and PL intensity profiles. The simulated IX PL intensity profile [Fig. 4(a)] is in qualitative agreement with the experiment [Fig. 2(c)]. Figure 4(b) shows an enhancement of the IX temperature in the excitation spot. Figure 4(d) shows the bare ramp potential U_{ramp} and the ramp potential with screening effects from the exciton-exciton repulsion taken into account $U_{\text{ramp}} + u_0 n_x$. Figures 4(c), 4(e), and 4(f) show the IX drift velocity, diffusion coefficient, and mobility, respectively. Their values are comparable to those for IX transport in devices where no electrode perforation is involved,^{7,8,14,24} indicating that the perforations do not cause additional substantial obstacles for IX transport. Figure 4(g) shows the average transport distance of IXs along the ramp M_1 as a function of exciton generation rate $\Lambda_0 = \Lambda(x=0)$. The units of Λ_0 in Fig. 4(g) can be transformed to the excitation power: $P_{\text{ex}} \sim \Lambda_0 A_{\text{ex}} E_{\text{ex}}/\alpha$, where A_{ex} is the excitation spot area, E_{ex} is the energy of a

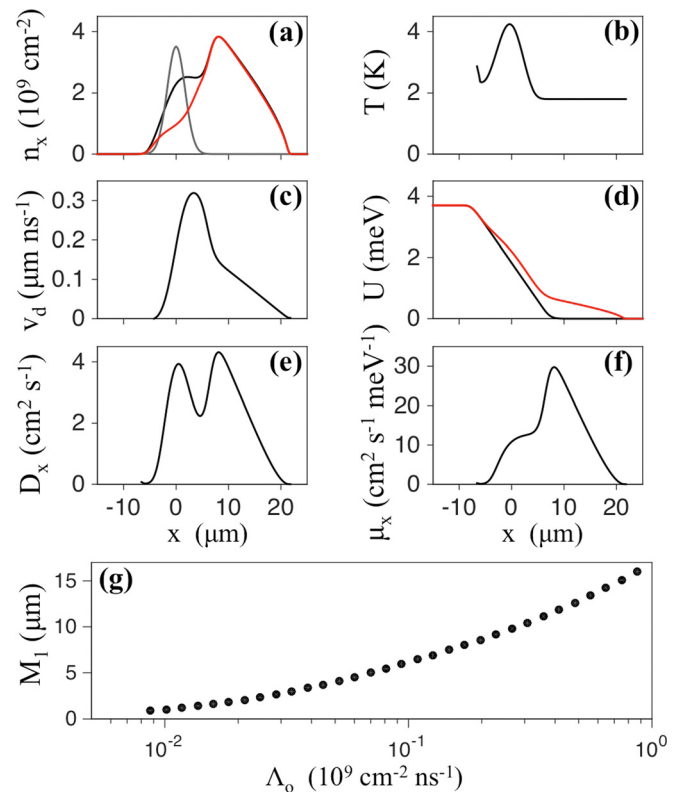


FIG. 4. Theoretical simulations. (a) IX density (black), IX PL intensity (red), and laser excitation profile (gray). (b) IX temperature. (c) IX drift velocity. (d) Ramp potential (black) and effective IX potential (red) due to the ramp potential plus exciton-exciton interaction. (e) IX diffusion coefficient. (f) IX mobility. $\Lambda_0 = 0.23 \times 10^9 \text{ cm}^{-2} \text{ ns}^{-1}$ and $T_{\text{bath}} = 1.8$ K for simulations (a)–(f). (g) The average IX transport distance along the ramp as a function of exciton generation rate Λ_0 . $T_{\text{bath}} = 1.8$ K.

photon in the laser excitation, and α is an assumed IX excitation probability per photon. We note that for the parameters in the experiment $A_{\text{ex}} \sim 30 \mu\text{m}^2$, $E_{\text{ex}} \sim 2 \text{ eV}$, and $\alpha \sim 0.01$, $\Lambda_0 = 10^8 \text{ cm}^{-2} \text{ ns}^{-1}$ transforms to $P_{\text{ex}} = 1 \mu\text{W}$, and the calculated $M_1 \sim 5 \mu\text{m}$ at $\Lambda_0 = 10^8 \text{ cm}^{-2} \text{ ns}^{-1}$ [Fig. 4(g)] corresponds to the measured $M_1 \sim 5 \mu\text{m}$ at $P_{\text{ex}} = 1 \mu\text{W}$ [Fig. 3]. The qualitative similarities between this model and the experimental data [compare Fig. 4(a) with Fig. 2(c) and Fig. 4(g) with Fig. 3] confirms that variations in the ramp potential due to the electrode perforations are small enough to not inhibit the mobility of IXs. We note that the theory gives a nonlinear increase of the IX-transport distance with IX density [Fig. 4(g)], mainly due to the nonlinear dependence of the IX diffusion coefficient on IX density, $D_x = D_x(n_x)$, given above.

In summary, we report on the realization of an electrostatic ramp for indirect excitons by generating a potential energy gradient with electrode density modulation. The electrode density gradient is achieved by perforating a single electrode of constant width. In contrast to the earlier shaped electrode method, the perforated electrode method does not limit the channel width, which, in turn, does not restrict the directed exciton fluxes. The perforated ramp device provides an experimental proof of principle for controlling exciton transport with electrode density gradients. The perforated electrode method gives the opportunity to create versatile potential landscapes for indirect excitons and create channels for directing exciton fluxes with the required geometry and energy profile.

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